

# Surface treatments for e-cloud mitigation

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**AT-VAC, TS-MME, AB/OP-RF-BI-ABP**

## Constraints for CLIC damping rings...and similar

The constraints in order to preserve beam quality are the following:

**For e-cloud, low secondary electron yield (SEY):**

$$\delta_{\max} < 1.3$$

**For the pressure:**

dynamic pressure below  $10^{-10}$  mbar

**NB: investigations in progress for the SPS to provide injection of nominal LHC luminosity and avoid electron cloud which would:**

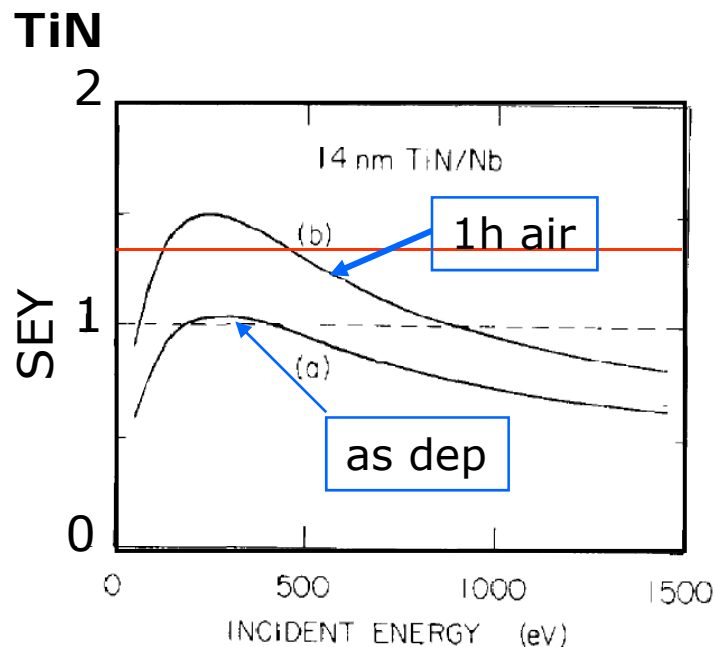
- increase the pressure by electron stimulated desorption
- provoke emittance growth
- provoke beam instability (head-tail, bunch-to-bunch coupling)
- interfere with the electrodes of beam monitors
- the threshold for electron cloud is also at  $\delta_{\max}=1.3$  (25 ns spacing)

**More on this in: <http://paf-spsu.web.cern.ch/paf-spsu/default.htm>  
by the SPSU team chaired by E.Shaposhnikova**

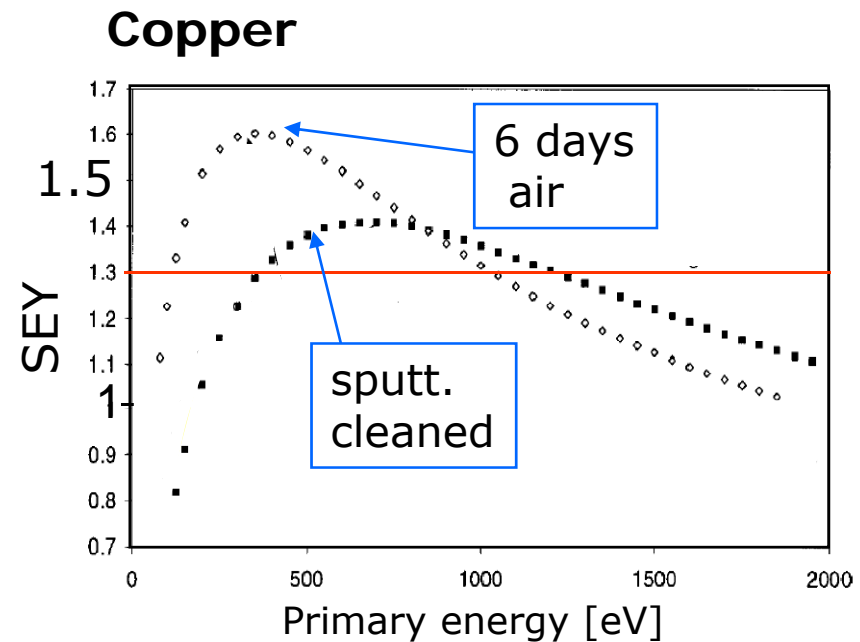
## Surfaces with initially low SEY: effect of air exposure (without bakeout)

**As deposited TiN** has a  $\delta_{\max} = 0.9-1.1$  ; **clean copper** has 1.3

Upon air exposure the TiN yield increases to  $\delta_{\max} = 1.5-2.5$  and the one of copper to  $\delta_{\max} = 1.6-2.6$

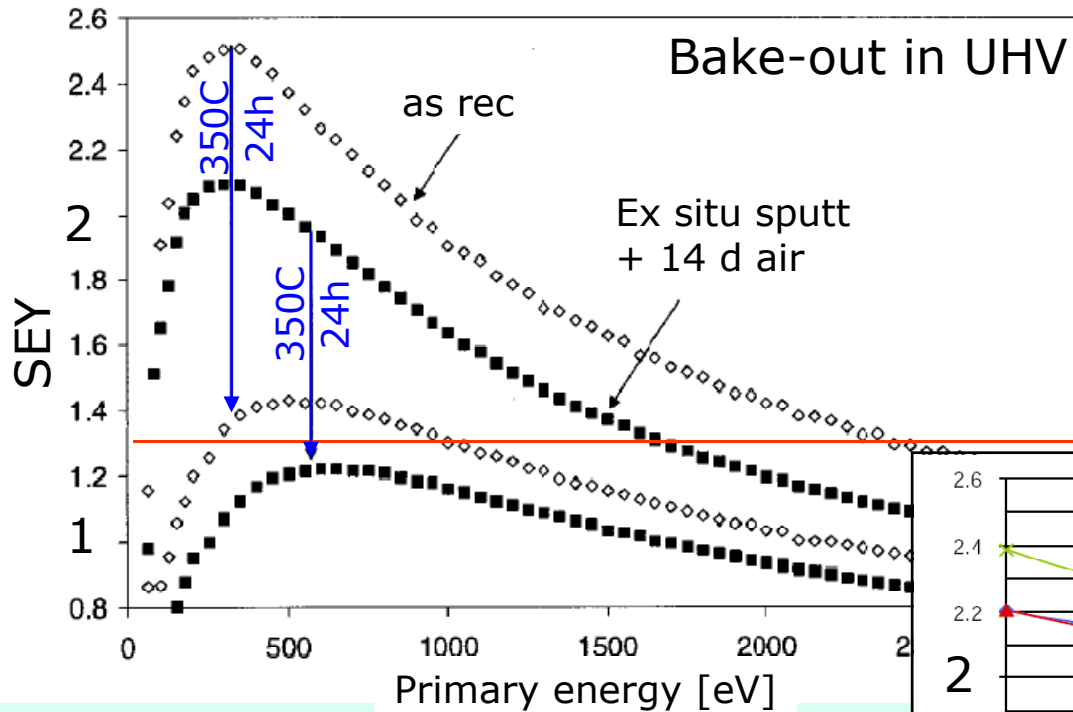


(E.L.Garwin et al. 1987)

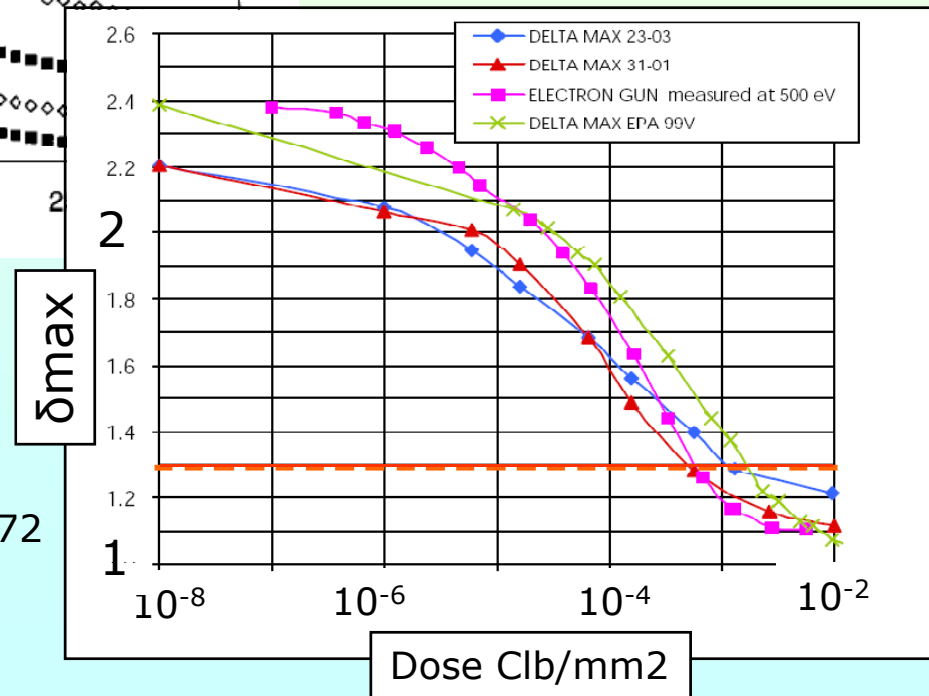


(Bojko, Henrist, Hilleret, Scheuerlein, 2000)

What can we gain with bakeout and conditioning?  
Ex: OFE-Copper



Conditioning with electrons



Bojko, Henrist, Hilleret,  
Scheuerlein JVST A18,972 2000

LHC Proj. rept. 472  
V.Baglin et al.

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Two cases to be discussed:

bakeable  
vacuum system



NEG coatings

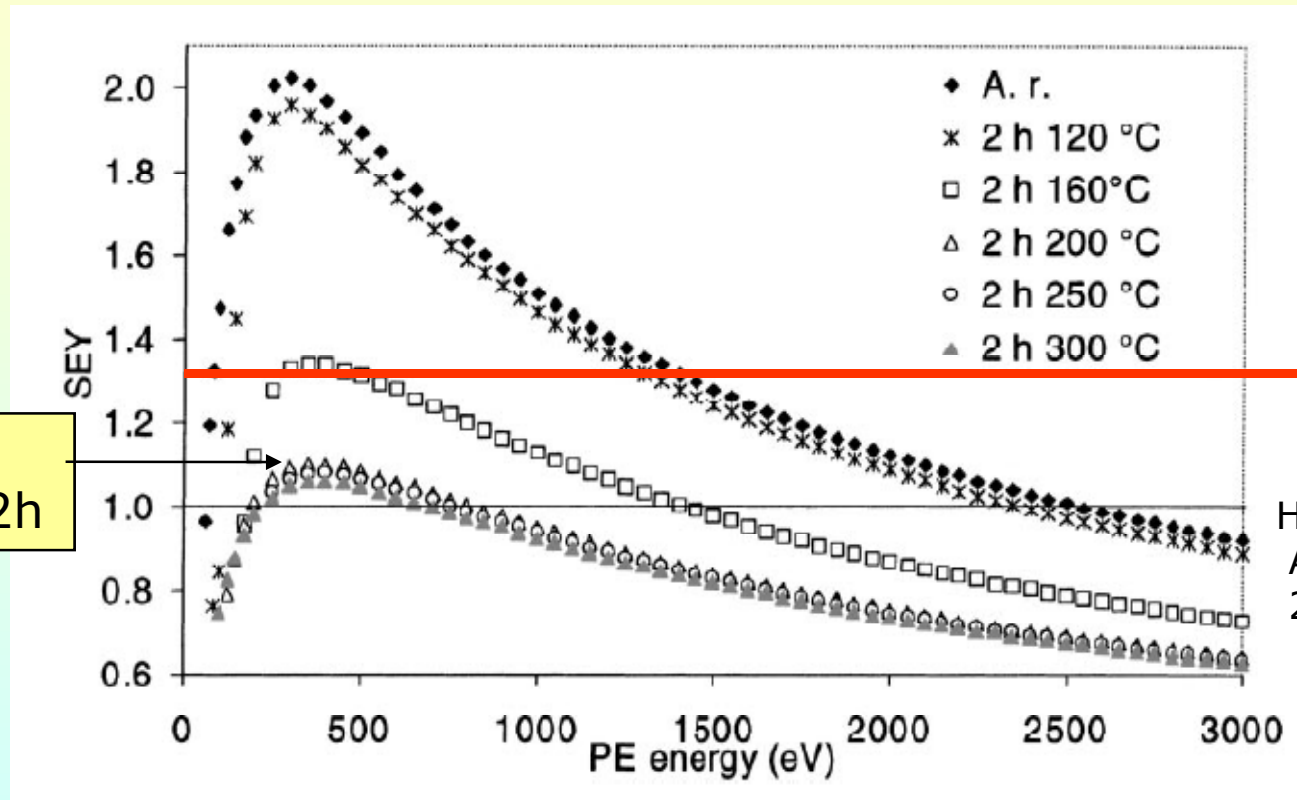
non-bakeable  
vacuum system



- Low SEY smooth coatings
- Macroscopically rough surfaces (not discussed here, can be used as substrate for low SEY coating)

## SEY: Non Evaporable Getter (NEG) coatings

TiZrV NEG can provide a surface with sufficiently low  $\delta_{max}$  :



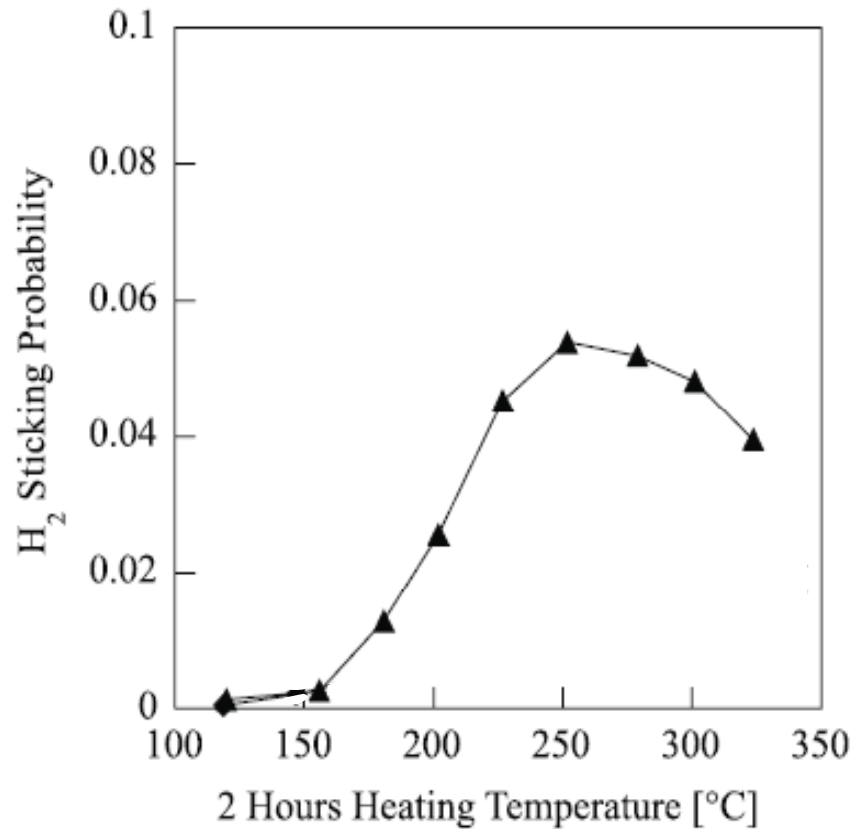
activation  
at 200C, 2h

1.3

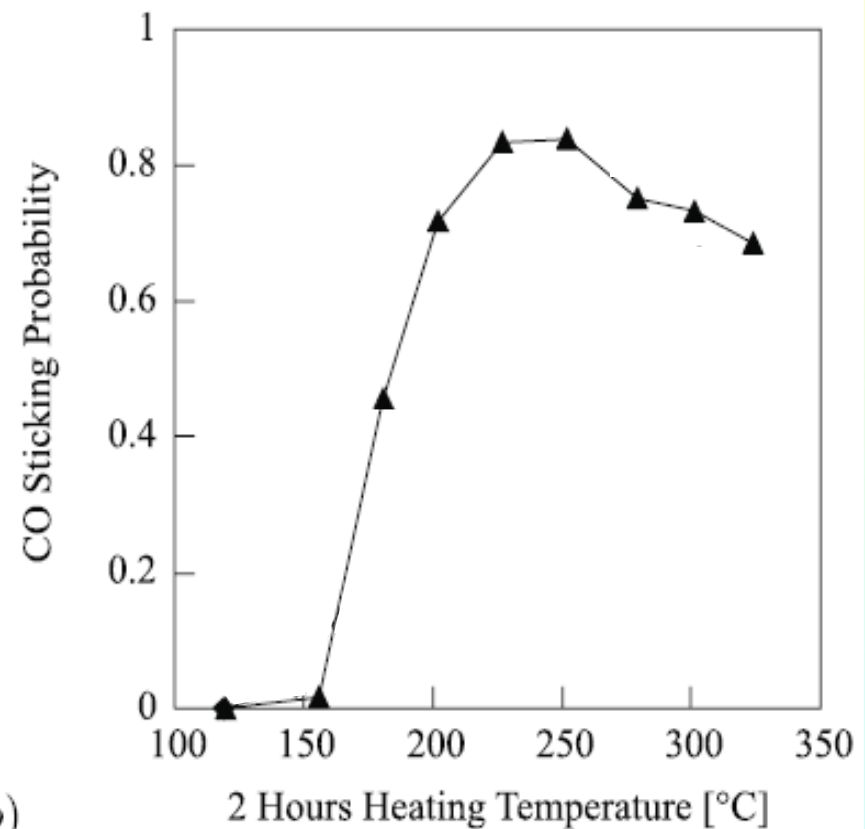
Henrist et al.  
Appl.Surf.Sci,  
2001

- Thermal activation is necessary: 2h at 200C or 24h at 180C
- data for 7 re-activations after air-venting do not indicate e-activity in SPS (A.Rossi, CERN report 2005)
- Already coated by magnetron sputtering LHC long straight sections (6 km, more than 1000 chambers) to provide pumping

Pumping action of NEG: sticking probability of H<sub>2</sub> and CO upon thermal activation



b)

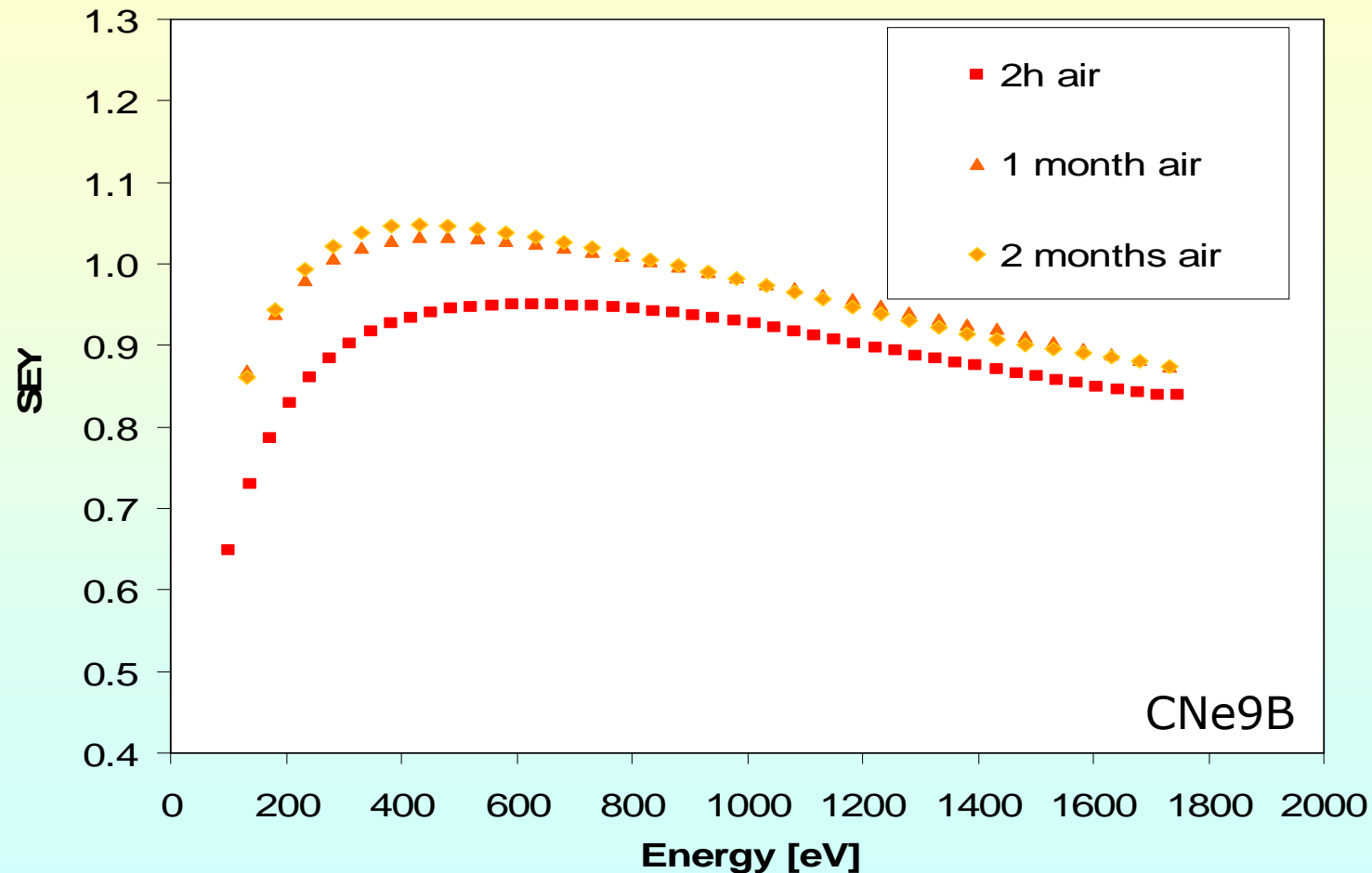


-the pumping speed decreases as  $1/n$  ( $n$ =number of venting/activation) and recovers by heating at higher T

Non-Bakeable sys.



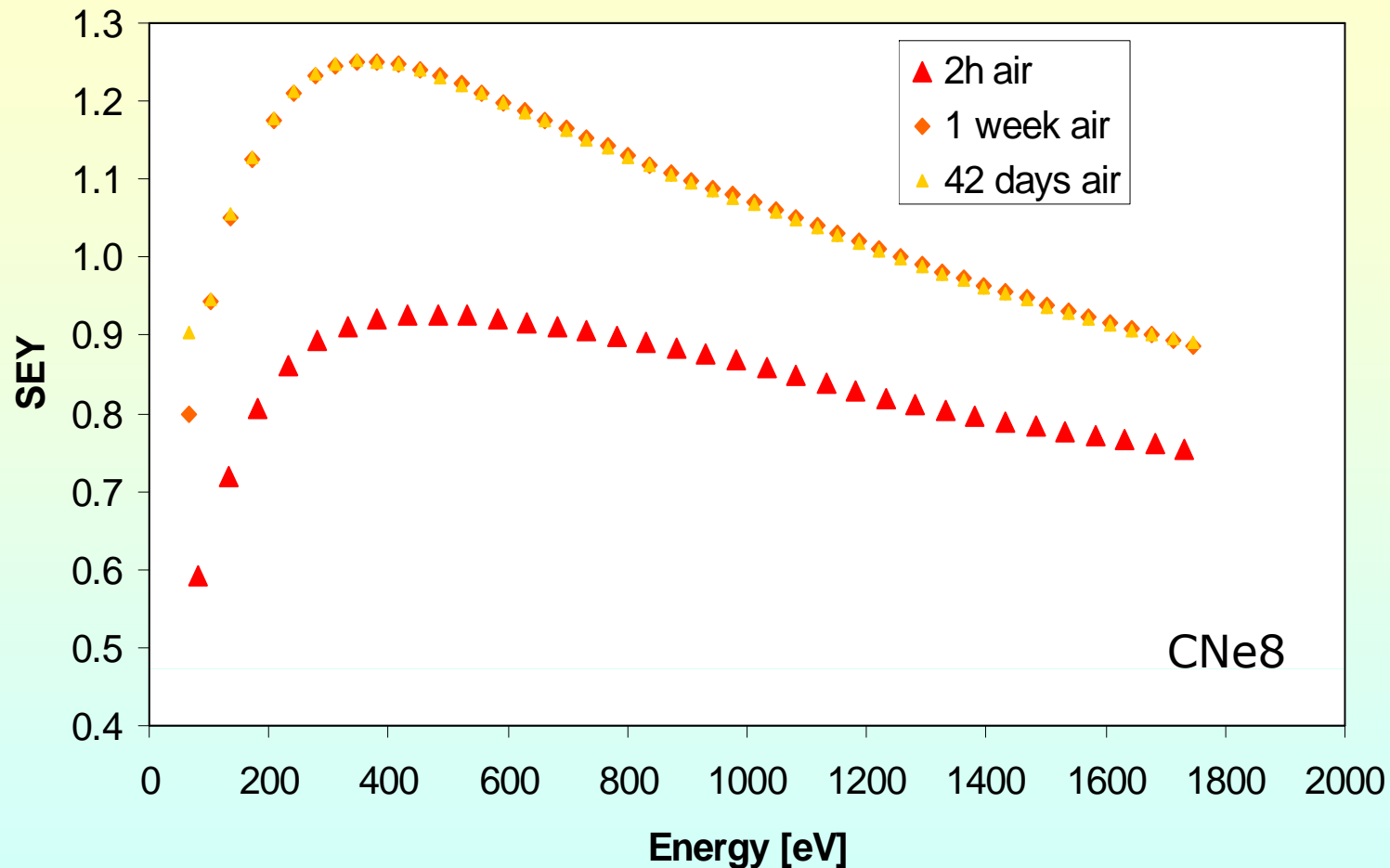
## Amorphous carbon a-C coating: low SEY without bake



-a-C coating on copper deposited by magnetron sputtering (Ne)  
-thickness from 60-1300nm has been successfully tested

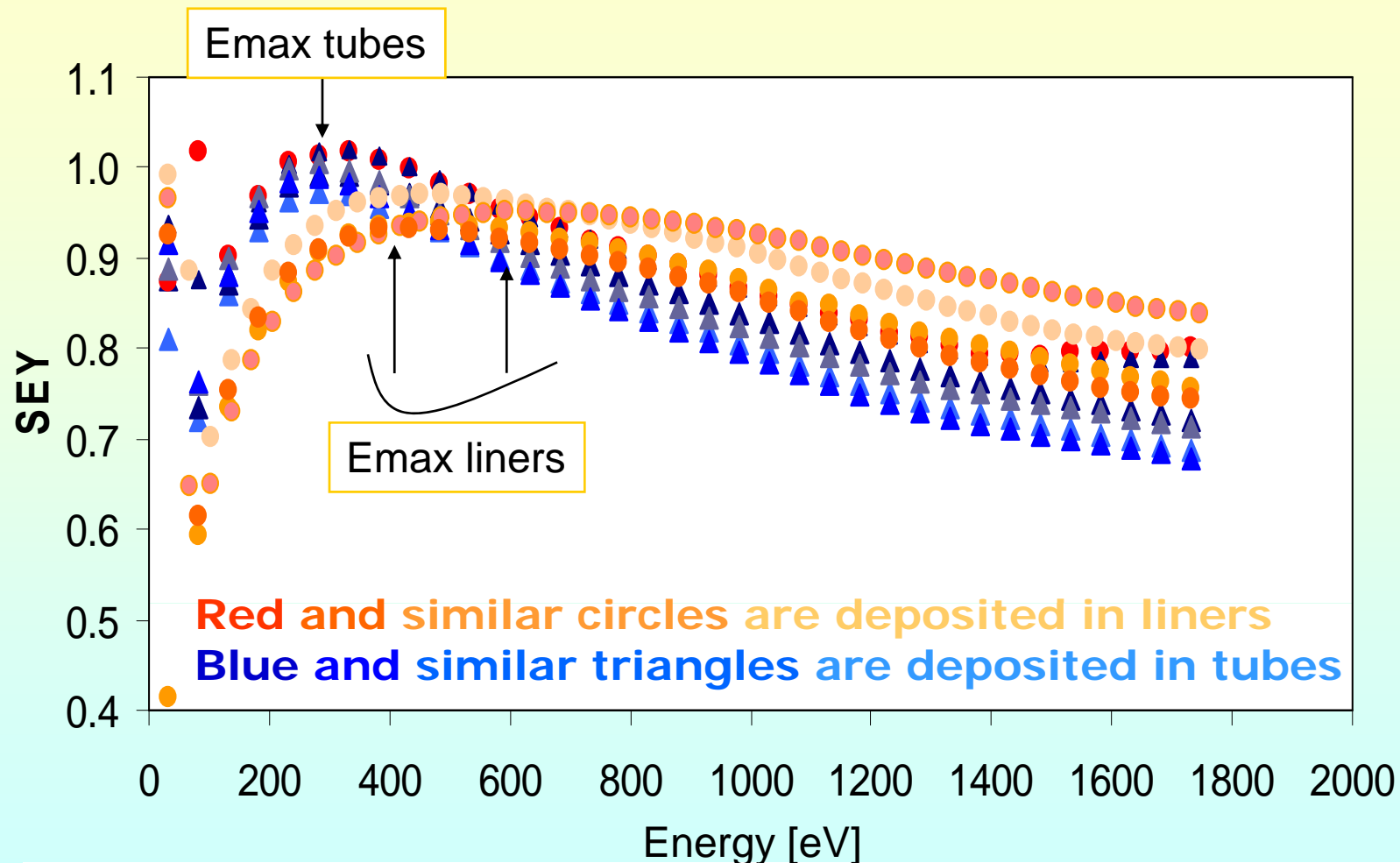
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## Amorphous carbon coating: "aging" in air



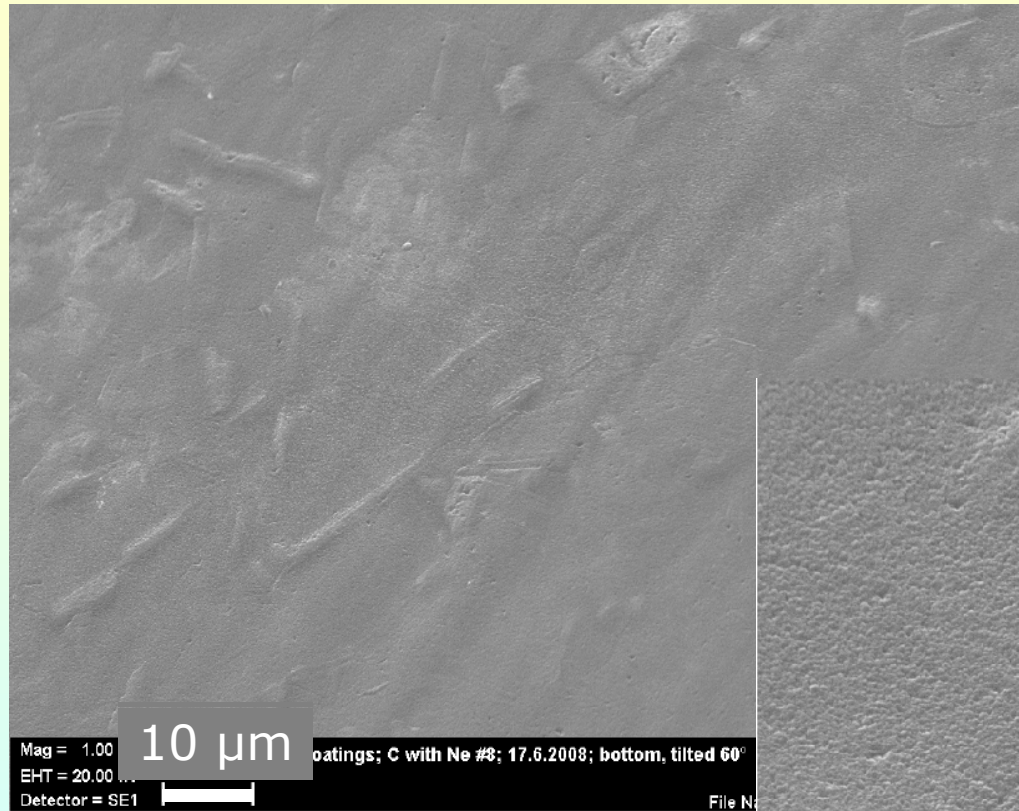
- The differences in "aging" in air are still under investigation
- It is important to specify a maximum air exposure time for the application!
- Can partly recover by bake 2h at 160C

## SEY curve dependence on sputtering configuration

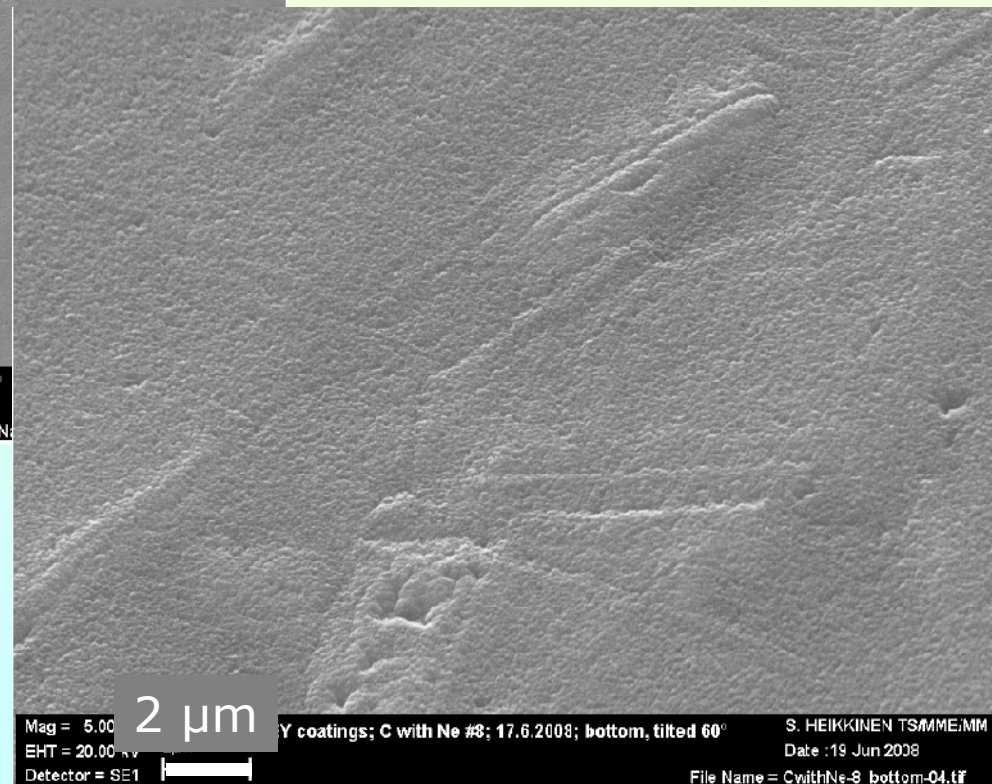


- possible differences in substrate T during deposition, atoms energy, angle of arrival on the substrate, (nano-)roughness.....
- related to differences in aging

SEM images of CNe8

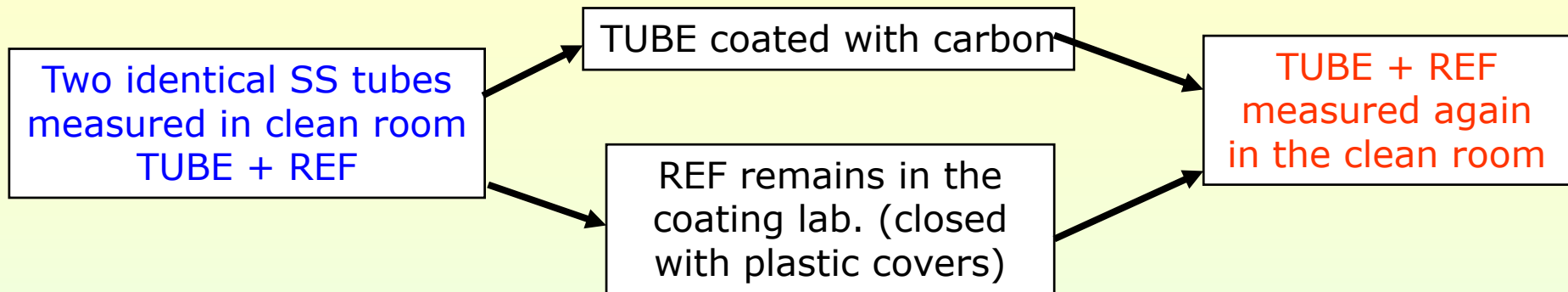


Good adhesion, no loose particles



Courtesy of S.Heikkinen

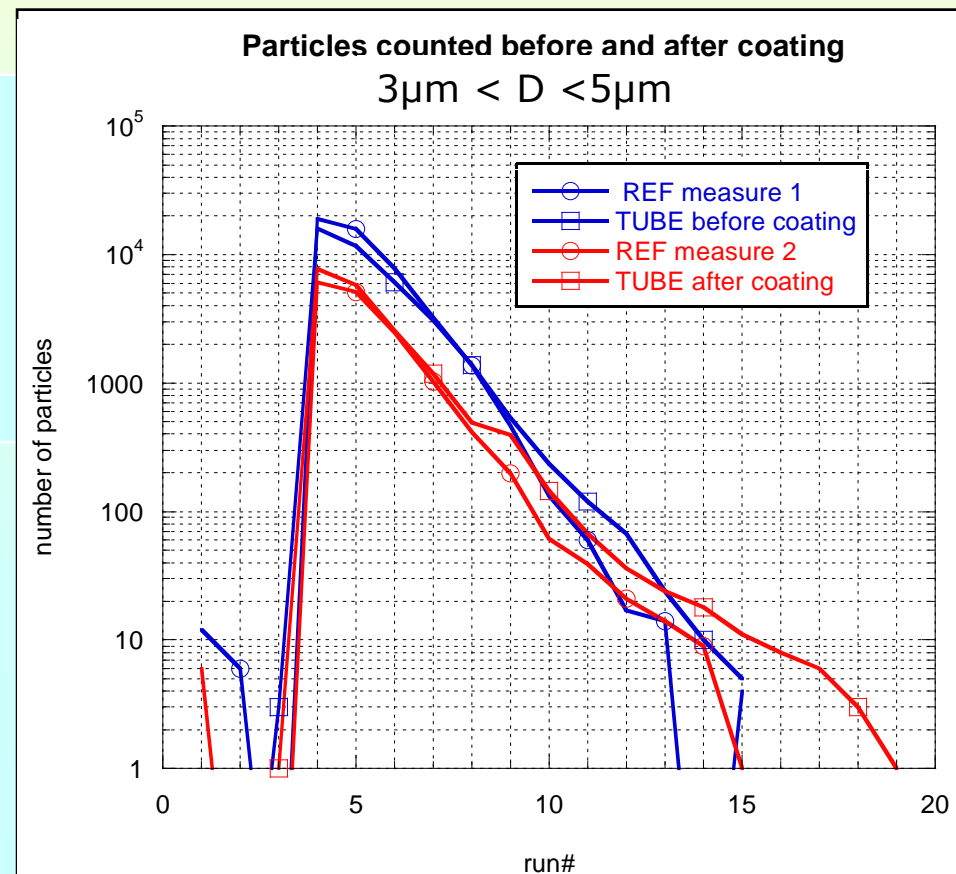
## Powder dust and particles: not an issue



Measured with an optical particle counter

- Same result for size above  $5\ \mu\text{m}$
- No increase after gentle hammering of the chamber

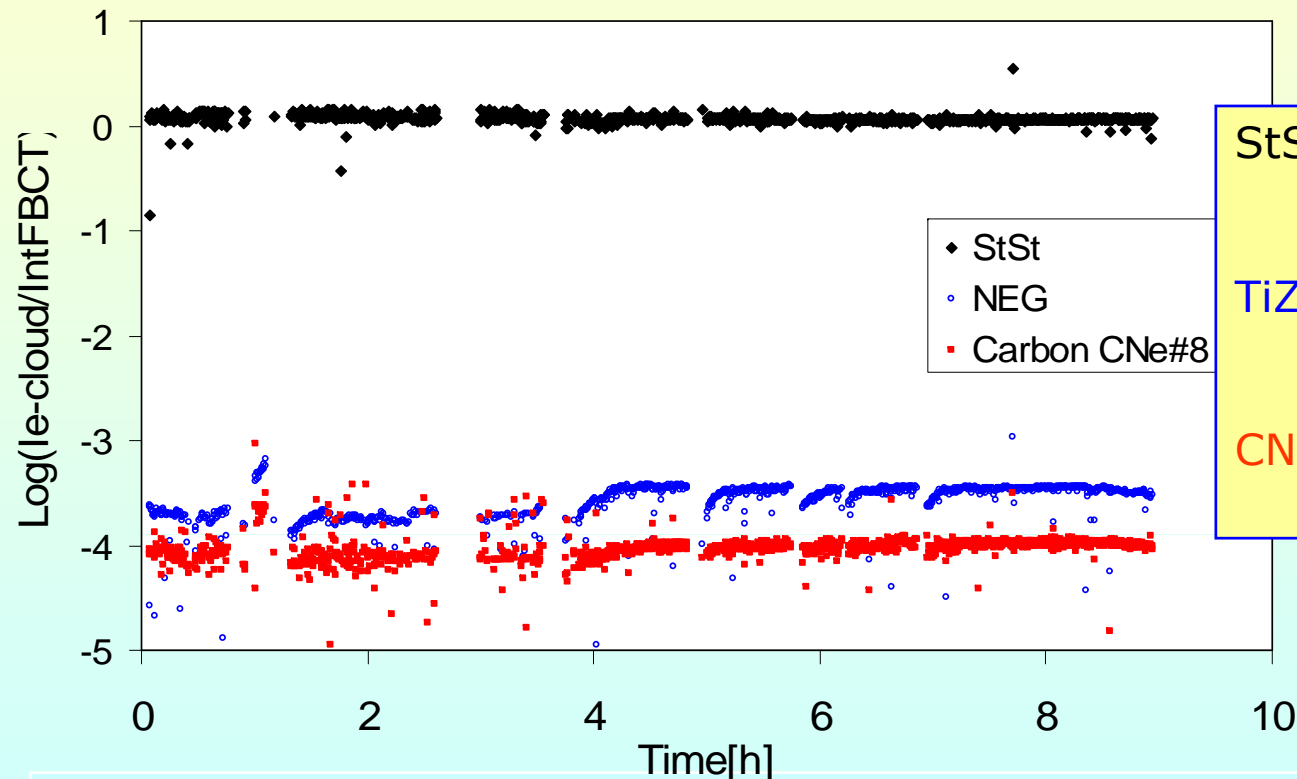
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## Strip detector in SPS, MD run w28

Set-up: a-C coated liner with strip detector in dipole magnet with  
1.2KGauss field

Beam: 2-3 batches, 72 proton bunches, 25 ns spacing, 450 Gev/c



StSt for 2h air exp.

$\delta_{\max}=2.5$

TiZrV-NEG fully activated

$\delta_{\max}=1.1$

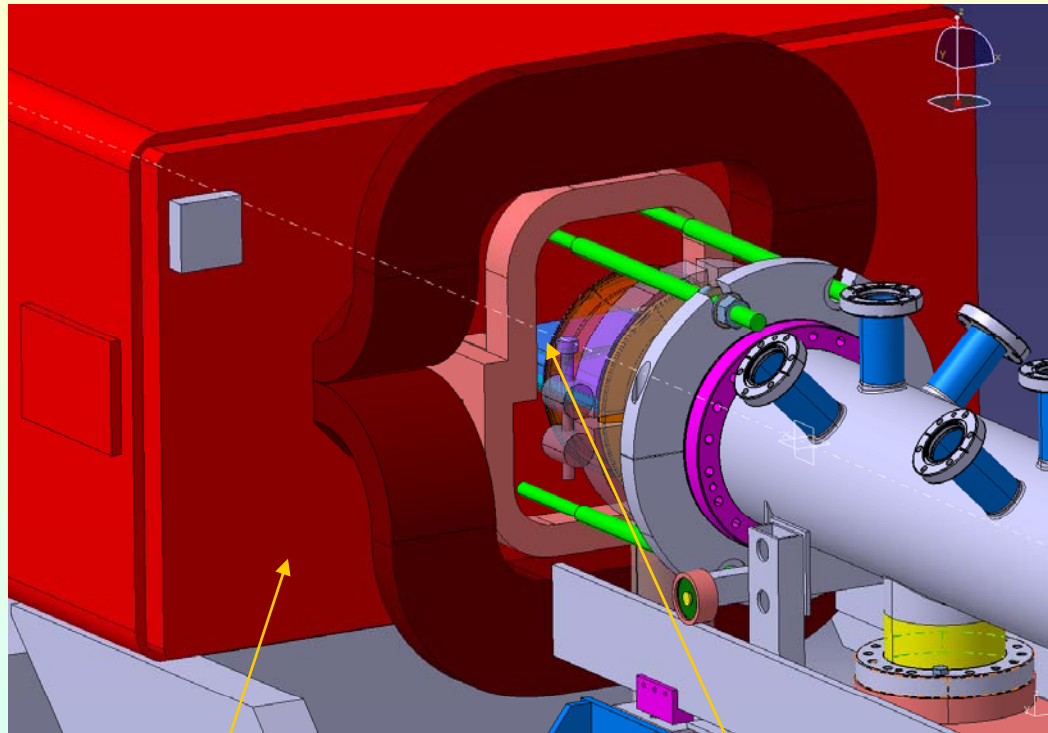
CNe for 2h air exp.

$\delta_{\max}=0.95$

-Coating CNe8 gives  $10^{-4}$  times current compared to SS, consistent with measured  $\delta_{\max}$

-same result for liner exposed 15 days to air (SPS MD run w33) or 2 months in the SPS vacuum (MD run week 41)

# Preparation for SPS magnet prototype coating



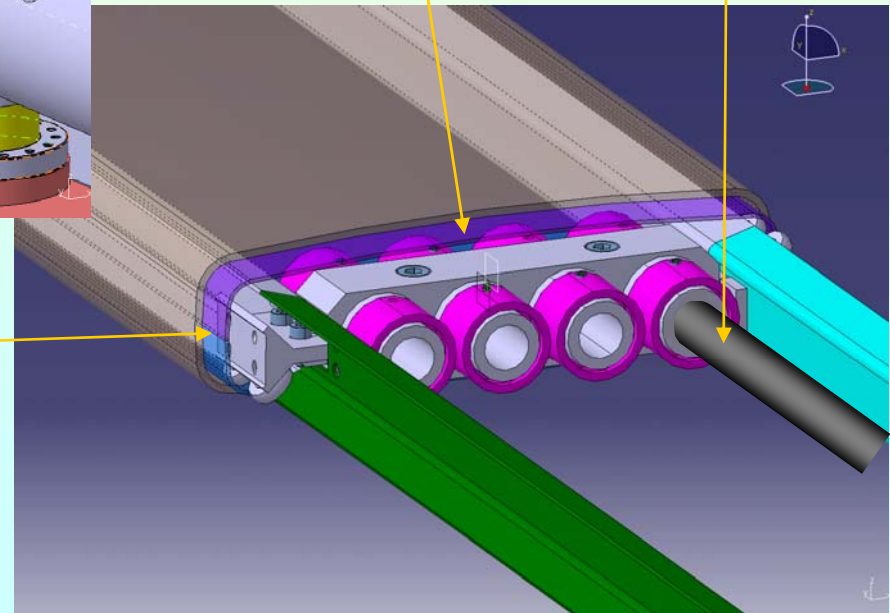
SPS dipole

vacuum chamber

Cathode insertion  
mechanism extraction

Liner to be coated

graphite  
cathode



## Conclusions:

### Bakeable system

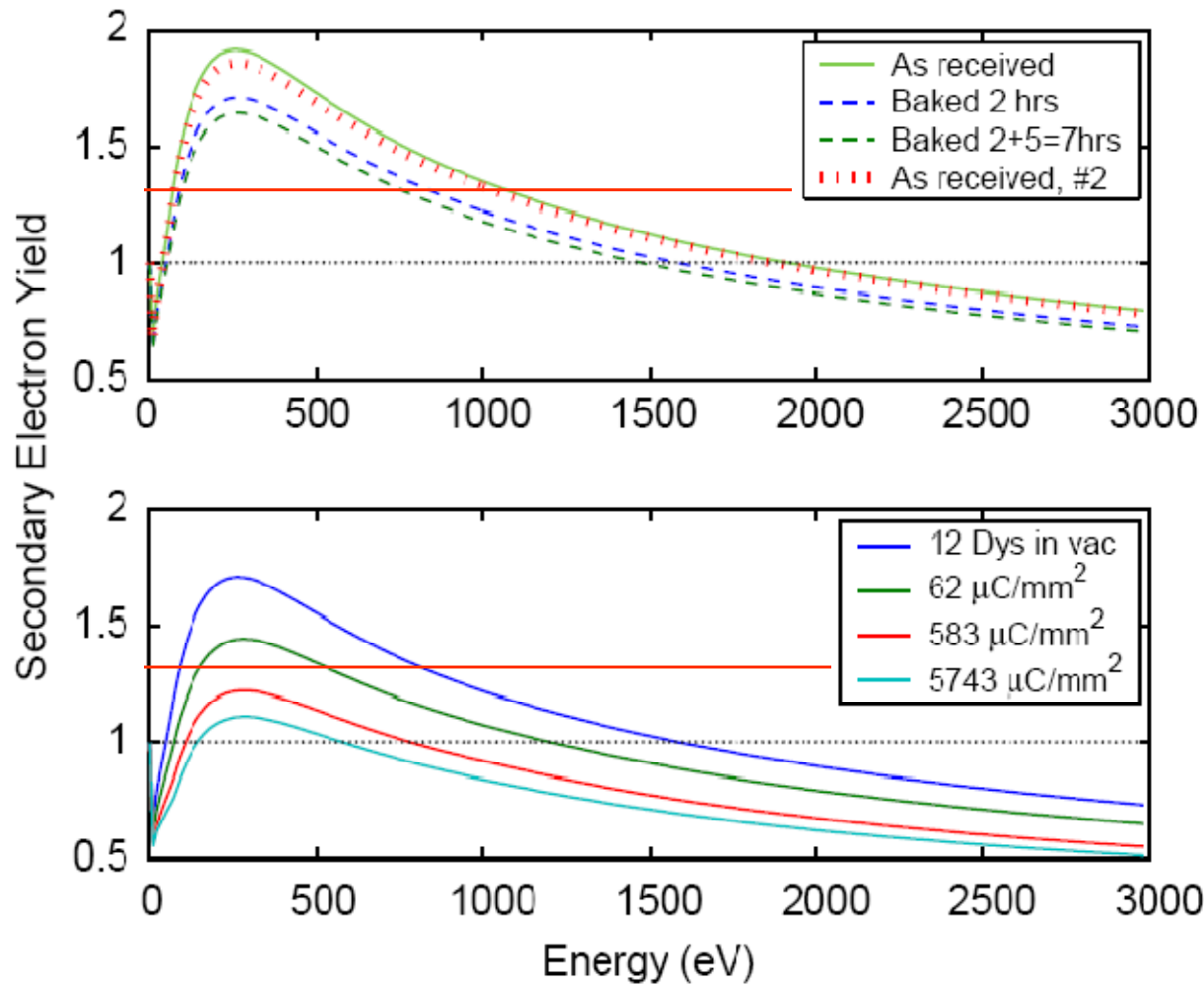
- NEG** is a valid solution for  $\delta_{\max} < 1.3$  if the system can be baked at 180C or higher
- the evolution after many venting cycles should be studied
- NEG provides pumping
- it is also conceivable to develop a coating with lower activation T

### Non-bakeable system

- a-C coating** provides  $\delta_{\max} \leq 1$  even after 2h air exposure
- aging of the coating in air is variable in the series of coatings produced so far, but  $\delta_{\max} < 1.3$  for 1 week air exposure
- after 2 months exposure in the SPS vacuum or 15 days air exposure the coatings do not show increase of e-cloud activity
- pumpdown curves can be as good as for stainless steel, depending on the deposition parameters, ESD and PSD measurements in progress (lab and ESRF)
- no particles and peel-off
- to be characterized for impedance and photoyield



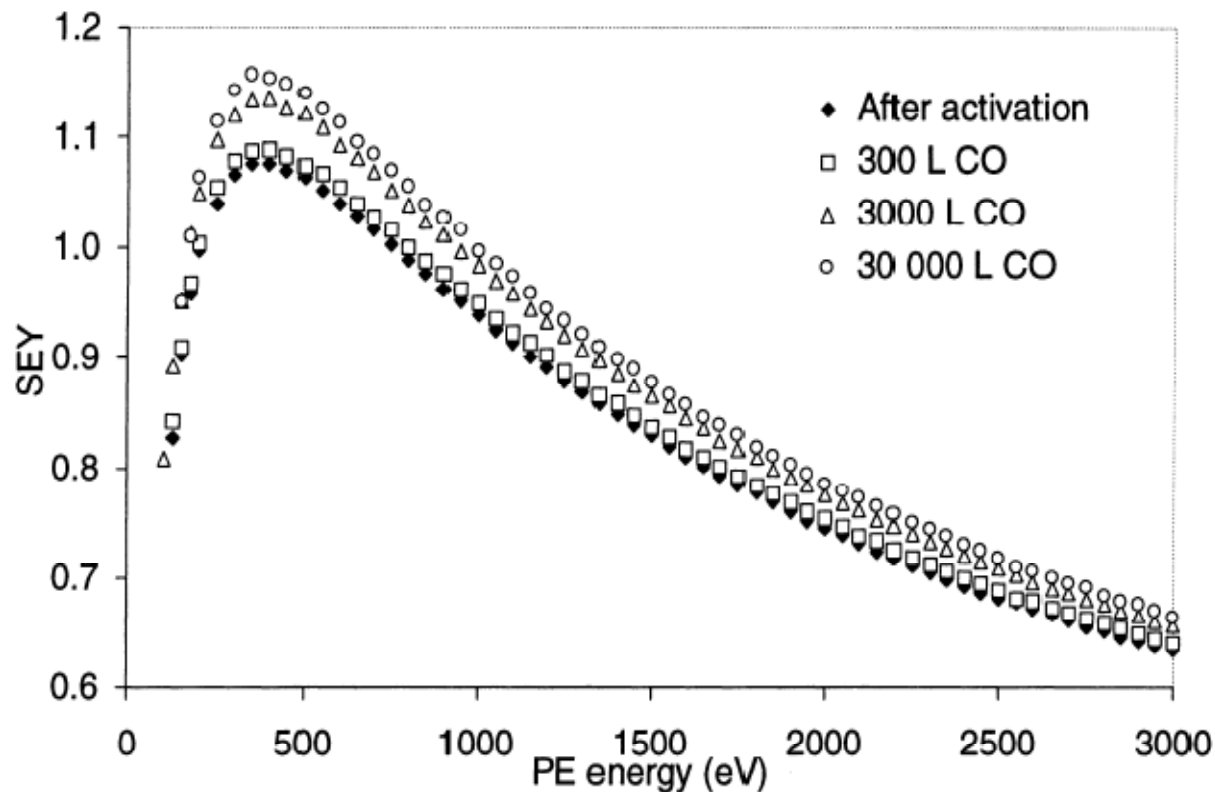
What can we gain with bakeout and conditioning?  
Ex: TiN



Bake 150C

Conditioning  
with electrons

## Effect of surface saturation by CO:



Henrist et al.  
Appl.Surf.Sci,  
2001

- The  $\delta_{max}$  remains below 1.3 even after surface saturation with CO (300 L correspond to 7 days at  $5 \times 10^{-10}$  mbar)
- Aging in air is less a concern, since re-activation for more than 20 times is possible

## **E-cloud data displayed as :**

Int e-cloud current/Int FBCT =

$$= \frac{\text{current, integrated over all strips, integrated over a supercycle}}{\text{FBCT signal, integrated over a supercycle}}$$

## **Dose calculated as:**

Dose [nC] = Current [nA] integrated over all strips, integrated over time and summed over the supercycles

NB: measured currents taken without consideration of transmission factor of the "grid" (7%)

## SEY of the inserted materials

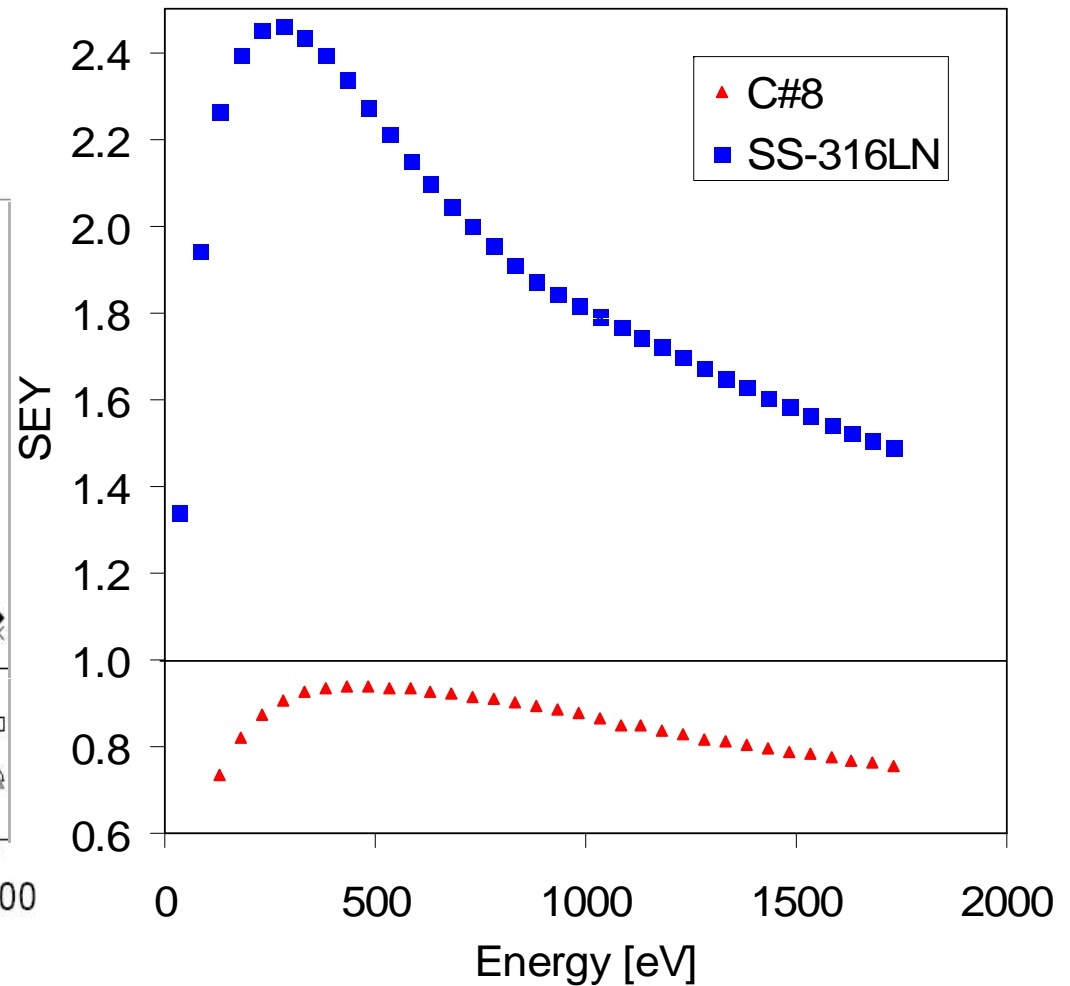
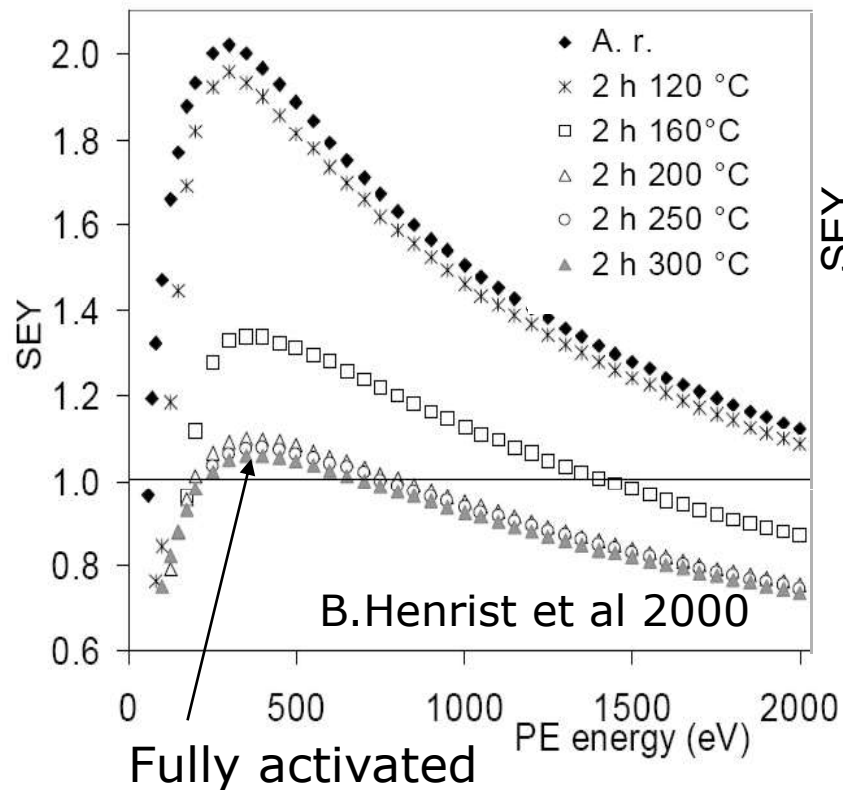
TiZrV-NEG,  
C#4, (scrub. run),  
C#8,(MD)  
SS,

$\delta_{\max}=1.1$  fully activated

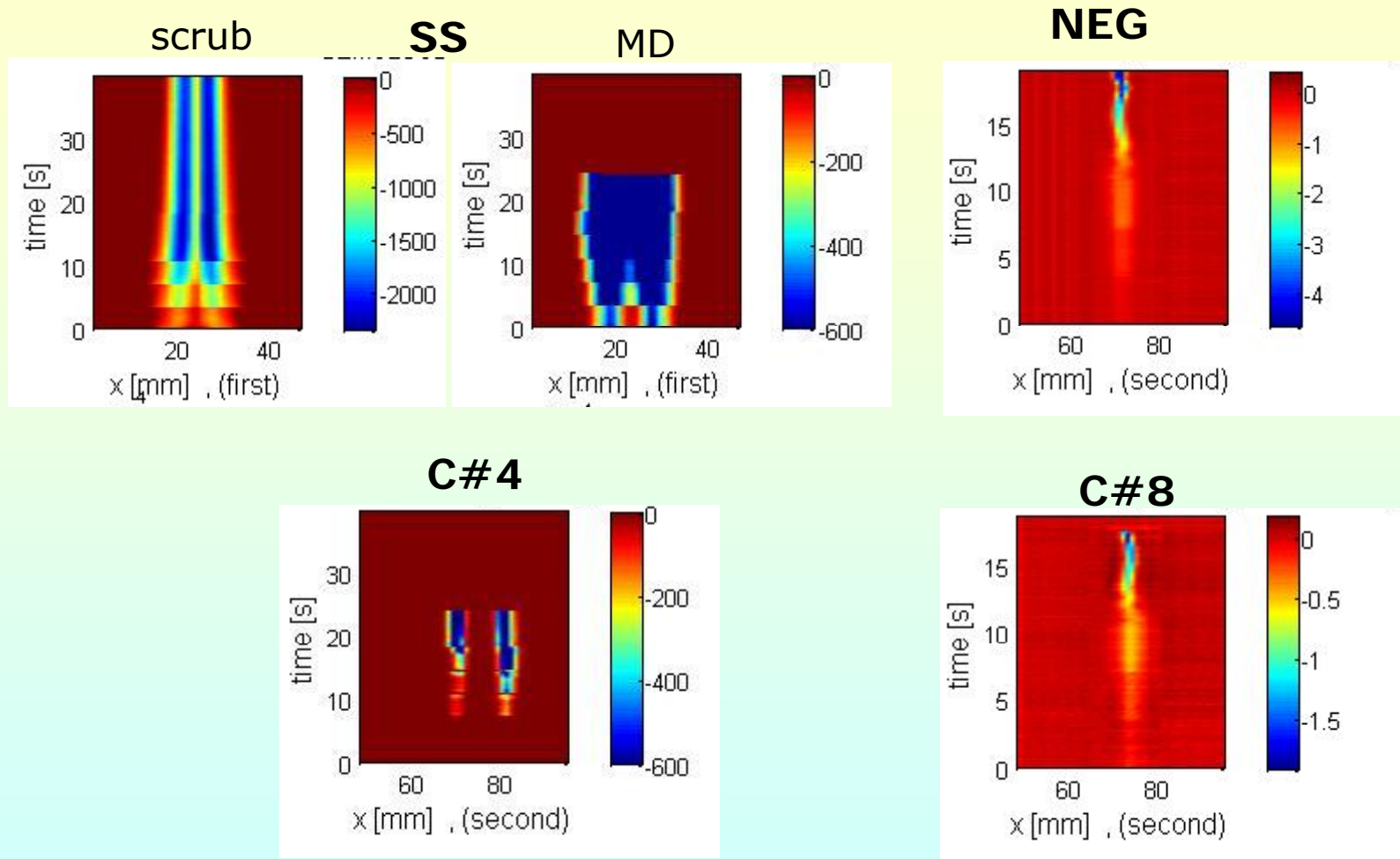
$\delta_{\max}\sim 1.4$  for 2h air exp. (measurements at 500eV only)

$\delta_{\max}=0.95$  for 2h air exp.

$\delta_{\max}=2.5$  for 2h air exp.



## Stripes and lines of both runs



The single stripe could be just due to ionization of residual gas; the order of magnitude is close

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## Perspective and problems:

- Characterize and reproduce the C#8 type coating
- SEY increases upon air exposure; the kinetic of the effect is presently investigated with measurements in the lab to define a typical "allowed" exposure
- Other remedies: possible combination of carbon with rough substrate

